



Atty. Docket No. 8013-1074

PATENTS

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4/1/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hidemitsu AOKI et al. Confirmation No. 6696

Serial No. 09/715,000 GROUP 2825

Filed November 20, 2000 Examiner Chuong A. Luu

IMPROVED SEMICONDUCTOR WAFER SURFACE
AND METHOD OF TREATING A SEMICONDUCTOR
WAFER SURFACE

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

The undersigned hereby petitions for an extension of time to respond to the Official Action of October 30, 2002 for two months to March 30, 2003.

Please charge the extension fee of \$410 to Deposit Account No. 25-0120. If this fee is insufficient, the Patent Office is hereby authorized to charge any additional extension fee to Deposit Account No. 25-0120. A duplicate copy of this sheet is enclosed.

A responsive paper is filed herewith.

Respectfully submitted,

YOUNG & THOMPSON

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By

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March 12, 2003

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